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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2811

Examiner: Quang D. Vu

In re PATENT APPLICATION of

Applicant(s) : Kazutaka SHIBATA

Appln. No. : 10/608,016

Filed : June 30, 2003

For : SEMICONDUCTOR DEVICE AND  
MANUFACTURING METHOD  
THEREOF

Atty. Dkt. : AI 288

**INFORMATION  
DISCLOSURE  
STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is an information disclosure statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(c), i.e., after a first Office Action on the merits but before Final Rejection and/or Notice of Allowance. Pursuant to 37 C.F.R. § 1.97(e)(2), it is certified the publication submitted with this Information Disclosure Statement was first cited in correspondence from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

Attached is a copy of one publication, which is listed on the attached Form PTO-1449, and whose relevance can be gleaned from the attached English-translation of a Japanese Office the Action issued in the corresponding Japanese application. Also listed is one U.S. patent. The document is listed on the attached Form PTO-1449.

Respectfully submitted,

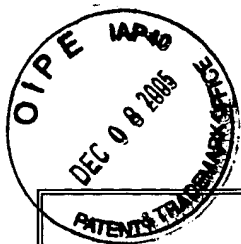
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December 8, 2005  
Date

SMR:pjl

**FEE ENCLOSED:\$**  
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<b>FORM PTO-1449</b> <b>INFORMATION DISCLOSURE STATEMENT</b>	Atty Docket <b>AI 288</b>	Application No. <b>10/608,016</b>
	Applicant <b>Kazutaka SHIBATA</b>	
	Filing Date <b>June 30, 2003</b>	Group Unit <b>2811</b>

**U.S. PATENT DOCUMENTS**

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA	2001-0010945	08/02/01	MIYAZAKI			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

**FOREIGN PATENT DOCUMENTS**

		Document Number	Date	Country	Class	Sub-Class	Translation
	AL	2002-230484	10/28/05	Japan			Abstract
	AM						
	AN						
	AO						

**OTHER (Including Author, Title, Date, Pertinent Pages, etc.)**

	AP	
	AQ	
	AR	

Examiner

Date Considered

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.